

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 243863US3DIV		SERIAL NO. New Application	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT Hitoshi SAKAMOTO, et al.					
		FILING DATE Herewith		GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
RRB	AA	6,440,494	08/02	Arena-Foster, Chantal			
RRB	AB	5,716,451	02/98	Hama et al.			
RRB	AC	5,292,370	03/94	Tsai et al.			
RRB	AD	5,980,687	11/99	Koshimizu, Chishio			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
RRB	AO	EP 573348 A1	12/93	European Patent (abstract only)	YES	NO	
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW						
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner <u>R. Bush</u>				Date Considered 12-2005			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Hitoshi SAKAMOTO, et al.			
		FILING DATE Herewith		GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
RRB	AA	4,626,448	12/02/86	A. K. HAYS			
RRB	AB	5,091,209	02/25/92	P. CLAVERIE, et al.			
RRB	AC	4,829,215	05/09/89	K. KIM, et al.			
RRB	AD	6,174,809	01/16/2001	Sang-bom KANG, et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES	NO	
	AO	0 482 265	04/29/92	EUROPE (submitting corr. US 5,091,209 and JP 2856782 only)			
RRB	AP	2856782	05/30/91	JAPAN		X	
RRB	AO	05-198520	08/06/93	JAPAN (submitting English Abstract only)			
RRB	AR	5-85890	04/06/93	JAPAN (submitting English Abstract only)			
RRB	AS	61-86942	05/02/86	JAPAN (submitting corr. US 4,829,215 only)			
RRB	AT	11-238698	08/31/99	JAPAN (submitting English Abstract and corr. US 6,174,809 only)			
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
RRB	AW	N. BOURHILA, et al., Microelectronic Engineering, vol. 33, pages 25-30, "COPPER LPCVD FOR ADVANCED TECHNOLOGY", 1997					
	AX						
	AY						
	AZ						
Examiner	<u>R. Bule</u>			Date Considered	12-2005		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							